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		_		Application Number 10/780,667			
11	NFORMATION	N DI	SCLOSURE	Filing Date	February 19, 2004		
S	STATEMENT BY APPLICANT			First Named Inventor	Hironori Ibusuki		
				Art Unit	1756		
	(Use as many she	eets a	necessary)	Examiner Name	N/A Young		
Sheet	1	of	1	Attorney Docket Number	SON-2920		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (# known)	Publication Date MM-OD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
CY	AA	5,831,272	11/3/98	Utsumi		
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FOREIGN PATENT DOCUMENTS							
Examiner	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Unes, Where Relevant Passages or Relevant Figures Appear	T°	
Initials*		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY				
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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (In CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
	CA	EPL: Electron beam Proximity Lithography, "Projection Exposure with Variable Axis Immercian Lonces: A High Throughput Electron Beam Approach to Suboptical Lithography" H.C. Pfeiffer, Jpn. J. Appl. Phys. Vol. 34 (1995) pp. 6658-6662	-		
_	GB	LEEPL: Low Energy Electron beam Proximity Projection Lithography, "Characterization of a Process Development Tool for Ion Projection Lithography, Hane Lecchner, et al., J.Vas. Sci. technol. B19, (2001)			
	CD	Complete copies have not been provided.			

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